## Akshay Gowda

## List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/9065789/publications.pdf

Version: 2024-02-01

1684188 1872680 9 99 5 6 citations g-index h-index papers 9 9 9 58 docs citations times ranked citing authors all docs

#	Article	IF	Citations
1	Almost Complete Removal of Ceria Particles Down to 10Ânm Size from Silicon Dioxide Surfaces. ECS Journal of Solid State Science and Technology, 2018, 7, P243-P252.	1.8	58
2	Cleaning Solutions for Removal of $\hat{a}^{-1}/430$ nm Ceria Particles from Proline and Citric Acid Containing Slurries Deposited on Silicon Dioxide and Silicon Nitride Surfaces. ECS Journal of Solid State Science and Technology, 2020, 9, 044013.	1.8	20
3	Trajectories, diffusion, and interactions of single ceria particles on a glass surface observed by evanescent wave microscopy. Journal of Materials Research, 2020, 35, 321-331.	2.6	8
4	Reactive Liquids for Non–Prestonian Chemical Mechanical Polishing of Polysilicon Films. ECS Journal of Solid State Science and Technology, 2019, 8, P3040-P3046.	1.8	6
5	Real-Time Visualization of the Cleaning of Ceria Particles from Silicon Dioxide Films Using PVA Brush Scrubbing. ECS Journal of Solid State Science and Technology, 2021, 10, 084004.	1.8	5
6	3D trajectories and diffusion of single ceria particles near a glass surface and their removal. Journal of Materials Research, 2021, 36, 258-267.	2.6	2
7	A Novel Method to Quantify Conditioner-to-Conditioner Variation and Predict Conditioner Lifetime and Process Failure Mode in Chemical Mechanical Planarization (CMP) Environment. IEEE Transactions on Semiconductor Manufacturing, 2020, 33, 614-621.	1.7	0
8	Selective Polishing of Amorphous Silicon Carbonitride (a-SiCN) Films Over Silicon Dioxide and Silicon Nitride Films for Hardmask Applications. ECS Journal of Solid State Science and Technology, 2020, 9, 034004.	1.8	0
9	3D trajectories and diffusion of single ceria particles near a glass surface and their removal. Journal of Materials Research, 2021, 36, 1-10.	2.6	O